



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

## ELECTRONIC COPY

### LABORATORY GROWN DIAMOND REPORT

December 23, 2025

IGI Report Number **LG759525917**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **7.97 - 8.04 X 4.96 MM**

#### GRADING RESULTS

Carat Weight **2.00 CARATS**

Color Grade **G**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

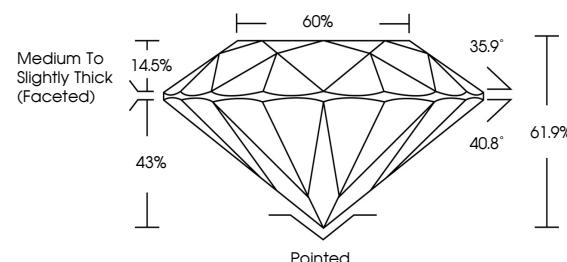
Inscription(s) **IGI LG759525917**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

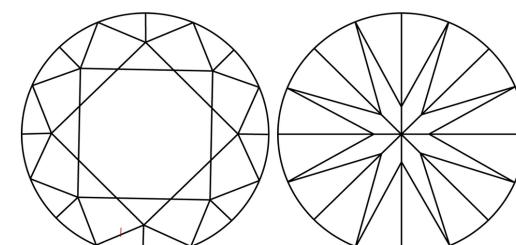
Type Ila

LG759525917  
Report verification at [igi.org](http://igi.org)

#### PROPORTIONS



#### CLARITY CHARACTERISTICS



#### KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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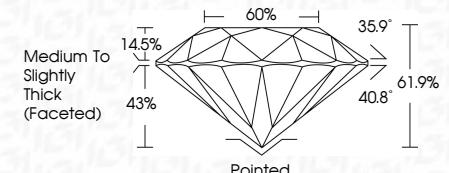
**EXCELLENT**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**



Sample Image Used



#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

**EXCELLENT**

Symmetry **NONE**

**NONE**

Fluorescence **Inscription(s)**

**IGI LG759525917**

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7.97 - 8.04 X 4.96 MM

Carat Weight	<b>2.00 CARATS</b>
Color Grade	<b>G</b>
Clarity Grade	<b>VS 1</b>
Cut Grade	<b>EXCELLENT</b>
Depth	61.9%
Table	60%
Girdle	Pointed
Medium To Slightly Thick (Faceted)	60%
Polish	<b>EXCELLENT</b>
Symmetry	<b>EXCELLENT</b>
Fluorescence	<b>NONE</b>
Inscription(s)	<b>IGI LG759525917</b>

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